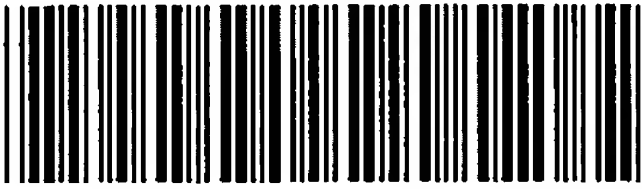


<div>Search Notes</div> <div></div>	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/020,543	MI ET AL.	
	Examiner	Art Unit	
	Mike Qi	2871	

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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
East search US-PGPUB;USPAT;USOCR; EPO;JPO;DERWENT;IBM_TDB; update search (see search history printout)	3/3/2006	ZQQ
The rejection is consulted and instructed under Primary Examiner Andrew Schechter and SPE Ken Parker.	3/8/2006	ZQQ